

10/099840
03/12/02

Jc3
866

PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10099840	FILING DATE 03/12/2002	CLASS 436	SUBCLASS	GAU 2812	EXAMINER Q. DANG
**APPLICANTS: Hofmann James;					
**CONTINUING DATA VERIFIED: NONE ^m					
** FOREIGN APPLICATIONS VERIFIED: NONE ^m					
PG-PUB <input type="checkbox"/> DO NOT PUBLISH <input type="checkbox"/> / RESCIND <input type="checkbox"/>					
Foreign priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no 35 USC 119 conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no Verified and Acknowledged Examiners's initials ^m				ATTORNEY DOCKET NO MI22-1803	
TITLE : Methods of forming patterns for semiconductor constructions; and molds configured to pattern masses associated with semiconductor constructions					

U.S. DEPT. OF COMMERCE / PAT & TM-PTO-436L (Rev. 12-94)

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims	Print Claim for O.G.
ISSUE FEE		DRAWING	
Amount Due	Date Paid	Sheets Drwg.	Figs. Drwg. Print Fig.
<input type="checkbox"/> TERMINAL DISCLAIMER		PREPARED FOR ISSUE WARNING: The information disclosed herein may be restricted. Unauthorized disclosure may be prohibited by the United States Code Title 35, Sections 122, 181 and 368, Possession outside the U.S. Patent & Trademark Office is restricted to authorized employees and contractors only.	

FILED WITH:

☐ DISK (CRF)

☐ CD-ROM

(Attached in pocket on right inside flap)